

# Interference Search History Printout MT

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	9	(nitride and semiconductor and nitride near buffer and nitride near layer and metal).CLM.	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	OFF	2005/10/11 10:40